



<b>Session Title:</b>	<b>[ThD2] Alternative Lithography II</b>
<b>Session Date:</b>	<b>November 14 (Thu.), 2024</b>
<b>Session Time:</b>	<b>10:50-11:50</b>
<b>Session Room:</b>	<b>Room D (Sidney Room, 2F, Paradise Hotel Busan)</b>
<b>Session Chair:</b>	<b>Prof. Myung-Ki Kim (Korea Univ., Korea)</b>

**[ThD2-1] [Invited]**

**10:50-11:20**

**III-V/Si Light Source Integration from on-Demand to Three-Dimensions**

You-Shin No (Konkuk Univ., Korea)

**[ThD2-2] [Invited]**

**11:20-11:50**

**Shadow Growth and Electrostatic Coating for Hybrid Nanoparticles**

Jang-Hwan Han, Doeun Kim, and Hyeon-Ho Jeong (GIST, Korea)